



# PRODUCT/PROCESS CHANGE NOTIFICATION

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PCN APM-PWR/09/4734  
Notification Date 07/21/2009

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**SILICON LINE CHANGE FOR BIPOLAR DEVICES - BB03 PRODUCT LINE**

**Table 1. Change Implementation Schedule**


|  |             |
|--|-------------|
| Forecasted implementation date for change  | 14-Oct-2009 |
| Forecasted availability date of samples for customer   | 14-Jul-2009 |
| Forecasted date for <b>STMicroelectronics</b> change Qualification Plan results availability | 14-Jul-2009 |
| Estimated date of changed product first shipment   | 20-Oct-2009 |

**Table 2. Change Identification**

|   |   |
|---|---|
| Product Identification<br>(Product Family/Commercial Product) | See attached list   |
| Type of change  | Waferfab process change   |
| Reason for change   | Production Optimization   |
| Description of the change                                     | Planar Base Island technology is ready to replace the mature Epibase technology in order to align our products to the actual Market. The line BB03 will replace the old ones F115. Feature: Improved hFE linearity and Higher fT frequency. Benefit: Better performances in switching and linear application. |
| Product Line(s) and/or Part Number(s)                         | See attached  |
| Description of the Qualification Plan                         | See attached  |
| Change Product Identification                                 | See "N" in additional info  |
| Manufacturing Location(s)                                     |   |

**Table 3. List of Attachments**

|                            |  |
|----------------------------|--|
| Customer Part numbers list |  |
| Qualification Plan results |  |

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|  |  |                              |
|--|--|------------------------------|
| Customer Acknowledgement of Receipt  |  | PCN APM-PWR/09/4734          |
| Please sign and return to STMicroelectronics Sales Office  |  | Notification Date 07/21/2009 |
| <input type="checkbox"/> Qualification Plan Denied<br><input type="checkbox"/> Qualification Plan Approved<br><br><input type="checkbox"/> Change Denied<br><input type="checkbox"/> Change Approved | Name:<br>Title:<br>Company:<br>Date:<br>Signature: |                              |
| Remark<br>.....<br>.....<br>.....<br>.....<br>.....<br>.....<br>.....<br>.....<br>.....  |  |                              |

## DOCUMENT APPROVAL

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# Reliability evaluation

## On

### BB03 for silicon line change

| General Information               |               | Locations              |                                 |
|-----------------------------------|---------------|------------------------|---------------------------------|
| <b>Product Lines</b>              | BB03          | <b>Wafer fab</b>       | Ang Mo Kio (SINGAPORE)          |
| <b>Product Description</b>        | Power BIPOLAR | <b>Assembly plant</b>  | SHENZHEN (China)                |
| <b>Commercial Product</b>         | BDW93C        |                        | LONGGANG (China)                |
| <b>Product Group</b>              | IMS – APM     | <b>Reliability Lab</b> | IMS-APM Catania Reliability Lab |
| <b>Product division</b>           | Power Bipolar |                        |                                 |
| <b>Package</b>                    | TO-220        |                        |                                 |
| <b>Silicon Process technology</b> | PLANAR NPN    |                        |                                 |

#### DOCUMENT INFORMATION

| Version | Date      | Pages | Prepared by | Approved by | Comment     |
|---------|-----------|-------|-------------|-------------|-------------|
| 1.0     | June-2009 | 6     | G.Montalto  | G.Falcone   | First issue |
|         |           |       |             |             |             |
|         |           |       |             |             |             |

Note: This report is a summary of the reliability trials performed in good faith by STMicroelectronics in order to evaluate the potential reliability risks during the product life using a set of defined test methods.  
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## **1 APPLICABLE AND REFERENCE DOCUMENTS**

| Document reference | Short description                                       |
|--------------------|---|
| JESD47             | Stress-Test-Driven Qualification of Integrated Circuits |

## **2 GLOSSARY**

|     |                   |
|-----|-------------------|
| DUT | Device Under Test |
| SS  | Sample Size       |
|     |                   |

## **3 RELIABILITY EVALUATION OVERVIEW**

### **3.1 Objectives**

Qualification of new silicon line BB03 for silicon line change on BDW93C device.

### **3.2 Conclusion**

The reliability tests have shown that the devices behave correctly against environmental tests (no failure). Moreover, the stability of electrical parameters during the accelerated tests demonstrates the ruggedness of the products and safe operation, which is consequently expected during their lifetime.

## **4 DEVICE CHARACTERISTICS**

### **4.1 Device description**

NPN Planar power transistors

### **4.2 Construction note**

**D.U.T.: BDW93C    LINE: BB03**

| Wafer/Die fab. information       |                             |
|----------------------------------|-----------------------------|
| Wafer fab manufacturing location | Ang Mo Kio (SINGAPORE)      |
| Technology                       | PLANAR NPN                  |
| Die finishing back side          | AuAs/Cr/Ni/Au               |
| Die size                         | 2490 x 2220 $\mu\text{m}^2$ |
| Metal 1                          | Al/Si                       |
| Passivation type                 | P-Vapox                     |

| Wafer Testing (EWS) information           |                        |
|---|------------------------|
| Electrical testing manufacturing location | Ang Mo Kio (SINGAPORE) |
| Test program                              | WPIS                   |

| Assembly information                |   |
|-------------------------------------|---|
| Assembly site                       | SHENZHEN, LONGGANG                          |
| Package description                 | TO-220                                      |
| Molding compound                    | Epoxy resin                                 |
| Frame material                      | Raw Copper                                  |
| Die attach process                  | Soft Solder                                 |
| Die attach material                 | 95.5%(Pb) / 2%(Sn) / 2.5%(Ag)               |
| Wire bonding process                | Ultrasonic                                  |
| Wires bonding materials/diameters   | Al/Mg Base / 7 mils<br>Al Emitter / 10 mils |
| Lead finishing/bump solder material | Pure Tin                                    |

| Final testing information |                    |
|---------------------------|--------------------|
| Testing location          | SHENZHEN, LONGGANG |
| Tester                    | IP test            |



## **5 TESTS RESULTS SUMMARY**

### **5.1 Test vehicle**

| Lot # | Process/ Package | Product Line | Comments      |
|-------|------------------|--------------|---------------|
| 1     | TO-220           | BB03         | Power BIPOLAR |

### **5.2 Reliability test plan and results summary**

#### **D.U.T.: BDW93C    LINE: BB03**

| Test                                  | PC | Std ref.      | Conditions  | SS  | Steps   | Failure/SS  |
|---------------------------------------|----|---------------|---|-----|---|---|
| <b>PRECONDITIONING OF SMD DEVICES</b> | -  | JESD22-A113-B | DRYNG 24H @ 125°C<br>STORE 168H @ TA=85°C<br>RH=85%<br>Reflow @ 260°C 3 times | 154 | Parameter deviation within spec. limits at end of preconditioning | No parameter deviation out of spec. limits at end of preconditioning. |
| <b>HTSL</b>                           | N  | JESD22 A-103  | Ta = 150°C  | 77  | 1000H   | 0/77  |
| <b>HTRB</b>                           | N  | JESD22 A-108  | T.A.=150°C Vdd=80V  | 77  | 1000H   | 0/77  |
| <b>THB</b>                            | Y  | JESD22 A-101  | Ta=85°C Rh=85%, Vdd=50V   | 77  | 1000H   | 0/77  |
| <b>TC</b>                             | Y  | JESD22 A-104  | TA=-65°C TO 150°C (1 HOUR/CYCLE)  | 77  | 500 cy  | 0/77  |
| <b>AC</b>                             | N  | JESD22 A-102  | Pa=2Atm / Ta=121°C  | 77  | 96 H  | 0/77  |

## **ANNEXES 6.0**

### **6.1 Tests Description**

| <b>Test name</b>                                | <b>Description</b>  | <b>Purpose</b>   |
|---|---|--|
| <b>THB</b><br>Temperature<br>Humidity Bias      | The device is biased in static configuration minimizing its internal power dissipation, and stored at controlled conditions of ambient temperature and relative humidity.   | To evaluate the package moisture resistance with electrical field applied, both electrolytic and galvanic corrosion are put in evidence.   |
| <b>HTRB</b><br>High Temperature<br>Reverse Bias | The device is stressed in static configuration, trying to satisfy as much as possible the following conditions: <ul style="list-style-type: none"> <li>• low power dissipation;</li> <li>• max. supply voltage compatible with diffusion process and internal circuitry limitations;</li> </ul> | To determine the effects of bias conditions and temperature on solid state devices over time. It simulates the devices' operating condition in an accelerated way.<br>To maximize the electrical field across either reverse-biased junctions or dielectric layers, in order to investigate the failure modes linked to mobile contamination, oxide ageing, layout sensitivity to surface effects. |
| <b>HTSL</b><br>High Temperature<br>Storage Life | The device is stored in unbiased condition at the max. temperature allowed by the package materials, sometimes higher than the max. operative temperature.  | To investigate the failure mechanisms activated by high temperature, typically wire-bonds solder joint ageing, data retention faults, metal stress-voiding.  |
| <b>AC</b><br>Auto Clave<br>(Pressure Pot)       | The device is stored in saturated steam, at fixed and controlled conditions of pressure and temperature.  | To investigate corrosion phenomena affecting die or package materials, related to chemical contamination and package hermeticity.  |
| <b>TC</b><br>Temperature<br>Cycling             | The device is submitted to cycled temperature excursions, between a hot and a cold chamber in air atmosphere.   | To investigate failure modes related to the thermo-mechanical stress induced by the different thermal expansion of the materials interacting in the die-package system. Typical failure modes are linked to metal displacement, dielectric cracking, molding compound delamination, wire-bonds failure, die-attach layer degradation.  |
| <b>TF</b><br>Thermal Fatigue                    | This test is performed to demonstrate the quality and reliability of devices exposed to cyclic variation in electrical stress between "on" and "off" conditions and resultant cyclic variation in device and case temperatures (thermo-mechanical stress).                                      | The purpose of this test is to detect assembly defects: improper die-attach, bonding weakness and thermal mismatch among various components of the package.  |

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